## **SIEMENS**

PATENT Attorney Docket No. 2001P17947WOUS

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Applica	ation of:		•	
Inventor: Serial No.: Filed:	A. Jeutter et al.	)	Group Art Unit:  Examiner:	1753 E. Wong
	10/659,219			
	September 10, 2003	j		
Title:	METHOD FOR COATING A SUBSTRATE HAVING HOLES			

**Commissioner For Patents** 

P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

## RESPONSE TO FINAL OFFICE ACTION

In response to the Final Office Action mailed August 9, 2007, Applicants respectfully submit the following amendments and remarks in connection with the above-identified application to place the claims in condition for allowance or to place the claims in better form for appeal.

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper